

1763

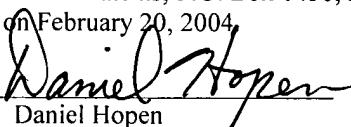
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
BASOL et al.
Serial No.: 10/017,494
Filed: December 7, 2001
Title: Planarity Detection Methods and Apparatus for Electrochemical Mechanical Processing Systems

Group Art Unit: 1763
Examiner: Culbert, Roberts P
Docket: 042496/0277563
NT-229-US

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the US Postal Service as First Class Mail in a postage-paid envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313 on February 20, 2004.

Signed: 
Daniel Hopen

AMENDMENT A

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Dear Sir:

A) In response to the Office Action mailed November 20, 2003 with a shortened statutory period for response no later than February 20, 2004, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper

Amendments to the Claims are reflected in the listing of claims which begins on page 5 of this paper.

Remarks/Arguments begin on page 13 of this paper.

B) Please change the correspondence address to the following address:

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